



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Paul Farrar

Title: CHEMICAL MECHANICAL POLISHING SYSTEM AND PROCESS

Docket No.: 1303.018US1

Filed: August 30, 2001

Examiner: Maurina Rachuba

Serial No.: 09/944,983

Due Date: December 9, 2004

Group Art Unit: 3723

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

- A return postcard.  
 Response Under 37 CFR 1.111 (23 Pages).

If not provided for in a separate paper filed herewith, Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

By: M L B

Atty: Marvin L. Beekman

Reg. No. 38,377

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 17 day of November, 2004.

Name

Kacia Lee

Signature

Kacia Lee

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)

3723

JRW



SN 09/944,983

PATENT

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RESPONSE UNDER 37 CFR § 1.111

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

This responds to the Office Action mailed on September 9, 2004.